AW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the Application of

Attn: OIPE

Toru YAMADA

Group Art Unit: 1722

Application No.: 10/582,802

Docket No.: 136170

Filed: June 14, 2006

For:

VAPOR PHASE GROWTH APPARATUS AND METHOD OF FABRICATING

EPITAXIAL WAFER

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

Ronald R. Snider

Registration No. 24,962

RRS:scg

Date: February 13, 2008

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10/582,802 06/14/2006 1722 900 SUG 192-PCT 136170

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Ronald R Snider PO Box 27613 Washington, DC 20038-7613



CONFIRMATION NO. 7018

FILING RECEIPT

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Date Mailed: 02/28/2007

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Applicant(s)

Toru Yamada, Gunma, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 28892.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/17193 11/18/2004

Foreign Applications JAPAN UNITED KINGDOM 2003-419201 12/17/2003

If Required, Foreign Filing License Granted: 02/08/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/582,802**

Projected Publication Date: 05/17/2007

Non-Publication Request: No

Early Publication Request: No

Title

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Vapor phase growth apparatus and method of fabricating epitaxial wafer

Preliminary Class

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